



PATENT

Docket No. 299002052200

Client Ref.: F5-0136063/98R00651/US/END

CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Express Mail Label No.: EV 232286132 US

Date of Deposit: April 2, 2003

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above and is addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Taryara Alcaraz

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Koji TAKAHASHI and Hidenori
KAWANISHI

Serial No.: 09/786,977

Filing Date: June 7, 2001

For: METHOD FOR FORMING COMOUND
SEMICONDUCTOR LAYER AND
COMPOUND SEMICONDUCTOR
APPARATUS

Examiner: J. Brophy

Group Art Unit: 2822

RECEIVED
APR - 9 2004
TECHNOLOGY CENTER 2800

AMENDMENT UNDER 37 C.F.R. §1.111

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

This is in response to the Office Action dated December 4, 2002 (Paper No. 9) for which a response was due on March 4, 2003 and for which a one month extension of time is also requested to extend the time for response from March 4, 2003 to April 4, 2003. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein is respectfully requested.

04/08/2003 HGUENAI 00000031 031952 09786977

01 FC:1201 84.00 CH